

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masuo SUZUKI et al.**

Serial Number: **Not yet assigned**
(§371 of international application No. PCT/JP2004/004820)

Filed: **September 30, 2005**

For: **POLISHING PAD, PRODUCTION METHOD THEREOF, AND
POLISHING METHOD USING THE SAME**

Attorney Docket Number: **053197**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 30, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08 and cited in the enclosed international search report. Since the documents were cited in the international search report, it is believed that copies of the documents have been transmitted by the International Bureau.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosures: PTO/SB/08 and International Search Report

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JC09 Rec'd PCT/PTO 30 SEP 2009

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| Combined Form PTO/SB/08A&B <u>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</u> <i>(use as many sheets as necessary)</i> | | | | <i>Complete if Known</i> | |
| | | | | Application Number | New Application |
| | | | | Confirmation Number | |
| | | | | Filing Date | September 30, 2005 |
| | | | | First Named Inventor | Masuo SUZUKI et al. |
| | | | | Art Unit | |
| | | | | Examiner Name | |
| Sheet | 1 | of | 1 | Attorney Docket Number | 053197 |

| U.S. PATENT DOCUMENTS | | | | | |
|-----------------------|-----------------------|-----------------|--------------------------------------|--------------------------------|---|
| Examiner Initials* | Cite No. ¹ | Document Number | | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document |
| | | Number | Kind Code ² (if known) | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
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| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | | | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Translation ⁶ |
| | | Country Code ³ | Number ⁴ | Kind Code ⁵ (if known) | | | |
| | 1 | JP | 2002-166352 | | 06-11-2002 | Kabushiki Kaisha Nissen | |
| | 2 | JP | 2003-80450 | | 03-18-2003 | Mitsui Chemicals, Inc. | |
| | 3 | PCT | WO 02/30617 | | 04-18-2002 | Cabot Microelectronics Corp. | |
| | 4 | JP | 2003-124163 | | 04-25-2003 | Hitachi Chemical Co., Ltd. | |
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| NON PATENT LITERATURE DOCUMENTS | | | |
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| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation ⁶ |
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